

Notice of References Cited

Application/Control No.

09/768,494

Applicant(s)/Patent Under
Reexamination
BUSKIRK ET AL.

Examiner

Allan W. Olsen

Art Unit

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-			
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	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Tea et al., Journal of Microelectromechanical Systems, Vol. 6, No.4, pages 363-372, December 1997.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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